



Docket No.: 49657-904

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Yoshinori TANAKA, et al.

Serial No.: 09/756,864

Group Art Unit: 2815

Filed: January 10, 2001

Examiner:

For: SEMICONDUCTOR DEVICE COMPRISING CAPACITOR AND METHOD OF  
FABRICATING THE SAME

*[Handwritten signature]*  
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26/13/01

SECOND PRELIMINARY AMENDMENT

Commissioner for Patents  
Washington, DC 20231

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

IN THE CLAIMS:

Claim 12, lines 21 through 24, please delete the unnecessary wording ", said part of said insulating film having a width being smaller than the minimum working size formable by photolithography".

REMARKS

Entry of this preliminary amendment is respectfully requested. A clean copy of claim 12 as amended is attached herewith.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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